

S/194/62/000/005/037/157 D222/D309

AUTHOR:

Yurascv. A.N.

TITLE:

A method of transforming relay circuits with mutually

exclusive contacts

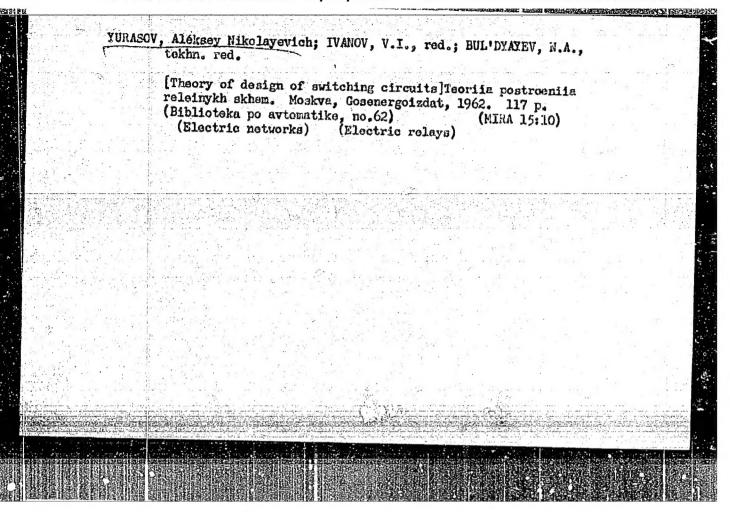
PERIODICAL:

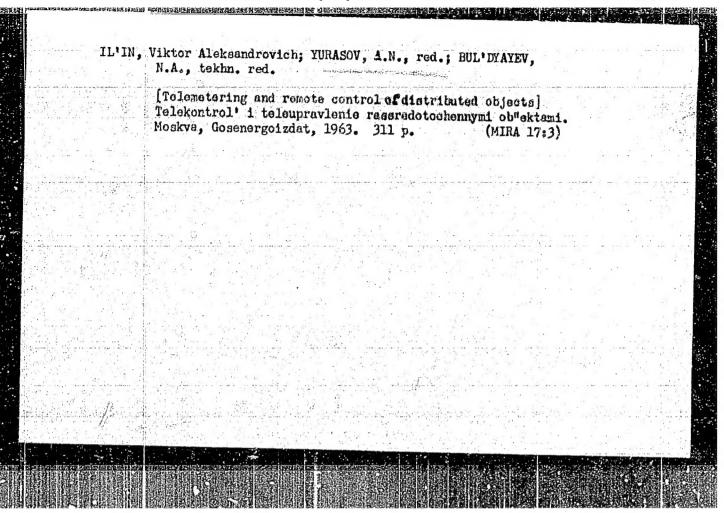
Referativnyy zhurnal. Avtomatika i radioelektronika, no. 5, 1962, abstract 5-2-125 i (Sb. statey. Vses. zaochn. politekhn. in-ta, 1960, no. 24, 135-142)

TEXT: A method of constructing relay-contact bridge circuits in which false chains are eliminated by mutually exclusive contacts is examined. The selection of such contacts is carried out by comparing the separate terms of the structural formula, first pairwise, then comparing the pairs, and so on. The following sequence of operation is recommended for circuits containing several reactive organs: 1) The brackets are removed in such a way that each term contains one reactive organ; 2) that pair of terms is selected which contains the largest number of common contacts, and which differs in the mutually-exclusive contacts of one element; the common contacts are put in front of the brackets; 3) analogously, each pair Card 1/2

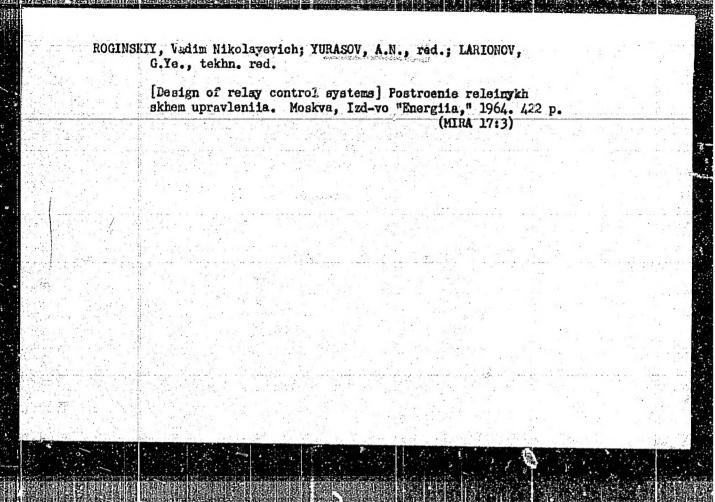
A method of transforming relay ... S/194/62/000/005/037/157

is united with a term of the formula which has not yet been united, while the different contacts are transferred to the right-hand side of the formula, and so; 4) the simplifications are carried out accorright sides of the formula are joined by the sign of multiterminal series connection. An example of circuit design is given. 2 references. [Abstractor's note: Complete translation].





APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"



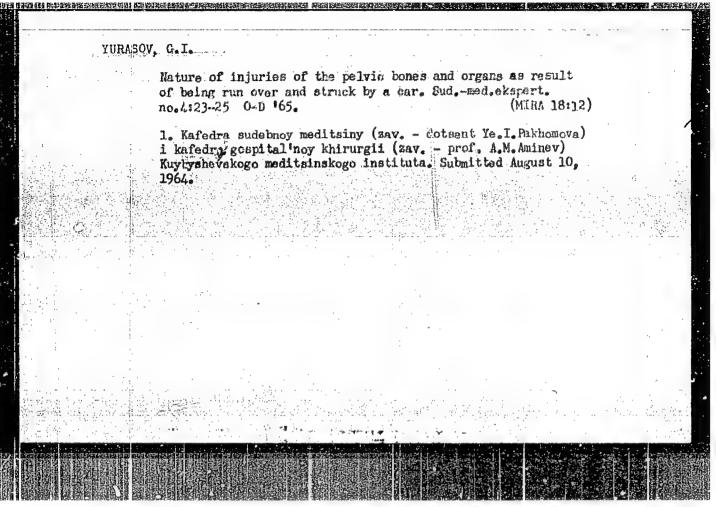
RAYNES, Roman Lazarevich; GORYANOV, Oleg Aleksendrovich. Prinimal uchastiye ZHOZHIKASHVILI, V.A., kand. tekhn. nauk; SUKHOPRUDSKIY, N.D., kand. tekhr. nauk, retsenzent YURASOV, A.N., red.

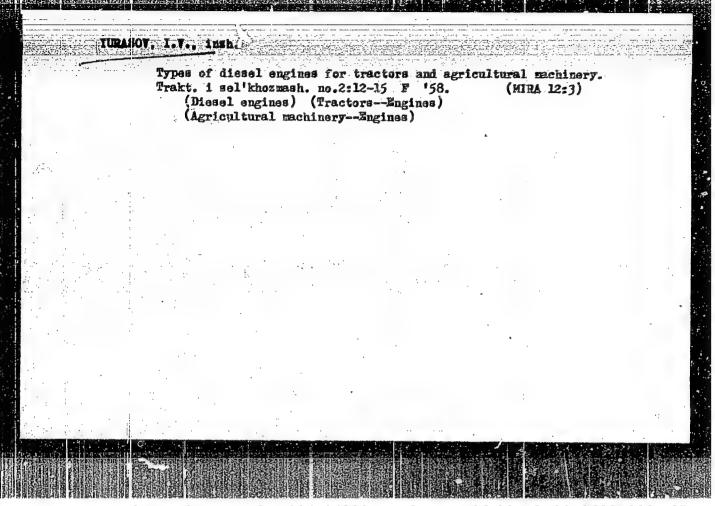
[Remote control] Teleupravlenie. Izd.2., perer. Moskva, Energiia, 1965. 535 p. (MIRA 18:2)

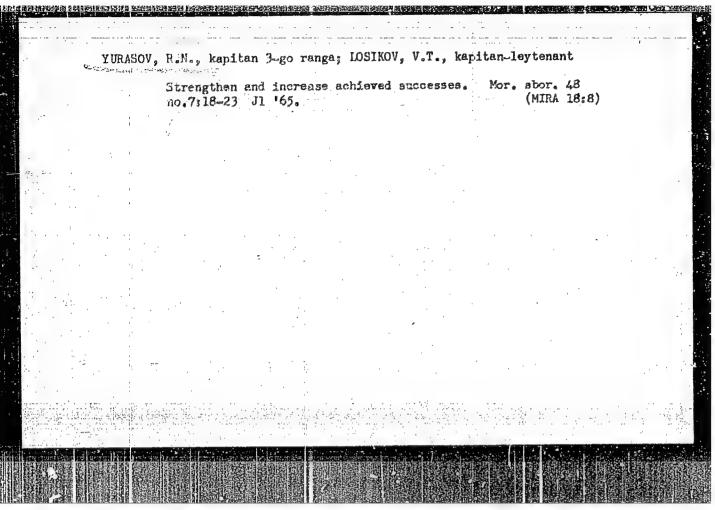
APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

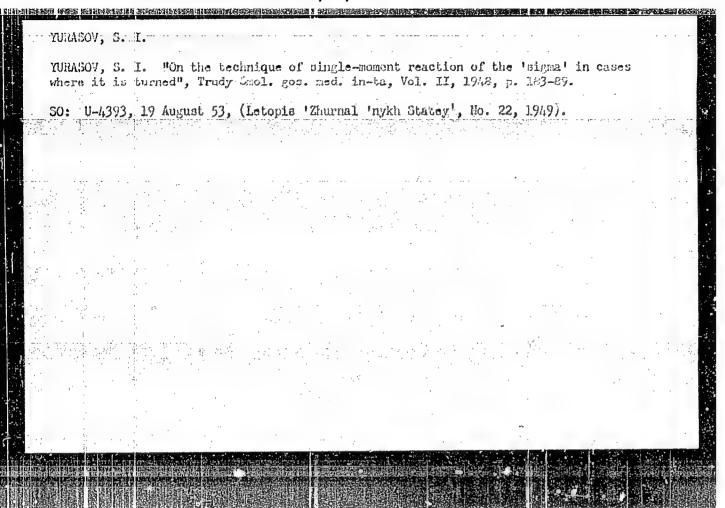
ZHILKIN, N.G.; YURASOV, A.V.; TROSTNIKOVA, N.Ta., red. izd-va;
IVANOVA, A.G., tekhn. red.

[Safety measures and industrial hygiene in the research institutes and laboratories of geological organizations]
Okhrena truda i proizvodstvennaia sanitariia v neuchno-issledovatel'skik institutakh i laboratoriiskh geologicheskikh organizatsii. Moskva, Gos. nauchno-tekhn. izd-vo litry po geol. i okhrene nedr, 1961. 178 p. (MIRA 15:3)
(Laboratories—Safety measures) (Geological research)

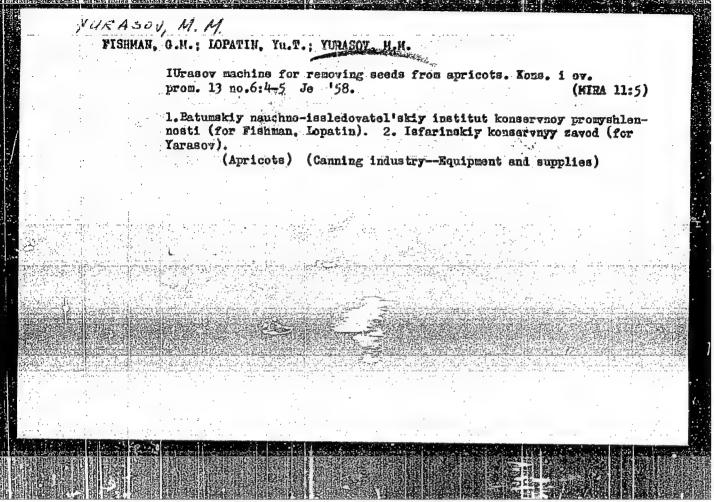




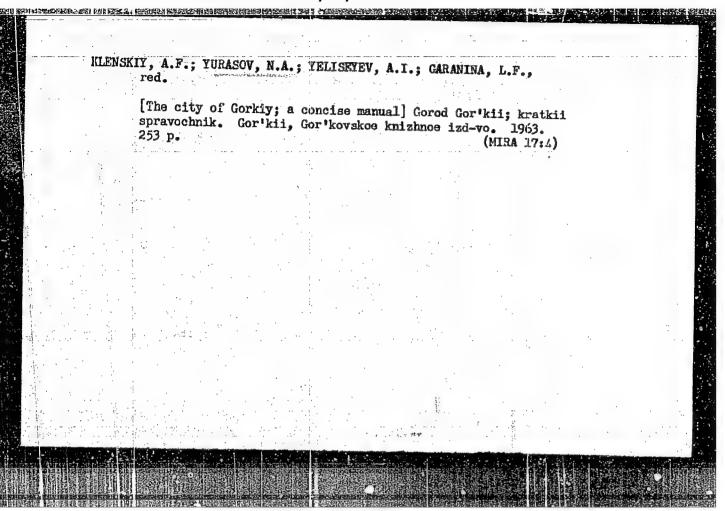


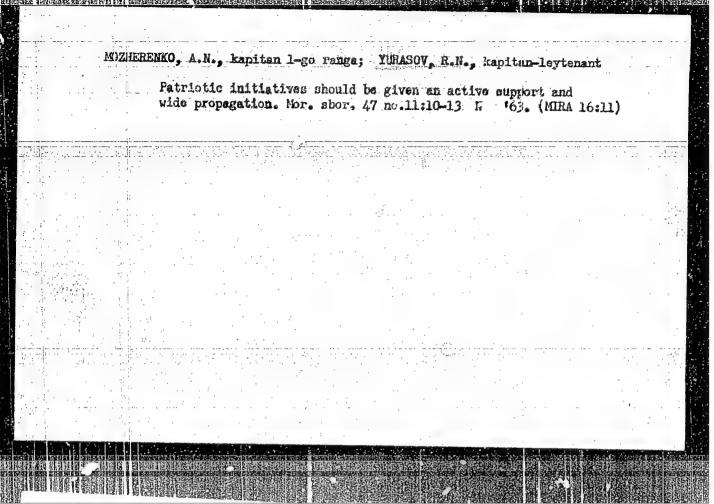


APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"



APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"





27423

9,6110 13002, 2605

3/120/61/000/002/038/042 E210/E594

Tul'chinskiy, B. S. and Yurasov, V. D.

TITLE 2

Card 1/3

Humidity Sensor Based on Using a Porous Semiconducting

PERIODICAL: Pribory i tekhnika eksperimenta, 1961, No.2, pp.183-184 The sensitive element is a semiconducting tin dioxide film with a porous surface produced by vacuum deposition on a porcelain core (20 x 5 x 1 mm) after preliminary drying at 150°C The film porosity and thickness can be easily controlled by varying the pressure and the temperature in the vacuum chamber. Porous tin dioxide films of thicknesses between 100 and 300 Å can also be produced by pyrolysis of tin tetrachloride onto the surface of a porcelain plate heated to 800-900°C and placed in a bell into which vapours of an alcohol solution of tin tetrachloride SnCl4 5H2O are fed in, together with a stream of dry By controlling the speed of feeding-in the mixture, the degree of saturation of the mixture with tin tetrachloride vapours, the duration of the process and the air humidity, porous films of the desired thickness can be obtained. A reliable contact between

27/23

Humidity Sensor Based on ...

S/120/61/000/002/038/042 E210/E594

the film and the electrodes is produced by vacuum deposition of thin silver and platinum electrodes. A good contact can also be obtained by soldering with indium without a flux. The dependence of the resistance ( $\lg 1/R$  vs.  $\varphi$ ,%) of the sensor on the relative humidity is plotted in Fig.1; it is reminiscent of the adsorption isotherm of water vapour on perous absorbents (A. Ya. Kuznetsov, h.fiz. khimii, 1959, 32, No.6, 1374). There is a jump in the electric conductivity between 30 and 40% of relative humidity, which is attributed to the beginning of capillary condensation in the pores. Absence of hysteresis indicates that the film does not interact Thus, the rectilinear section of curve 1 can be applied for determining relative humidities between 40 and 95% with an accuracy of about 1% compared to psychometric measurements which were applied for calibrating the instrument, On a semilogarithmic plot the temperature dependence is practically linear; at room temperature the temperature coefficient is about 0.86%/°C. There are 2 figures and 9 references: 8 Soviet and 1 non-Soviet.

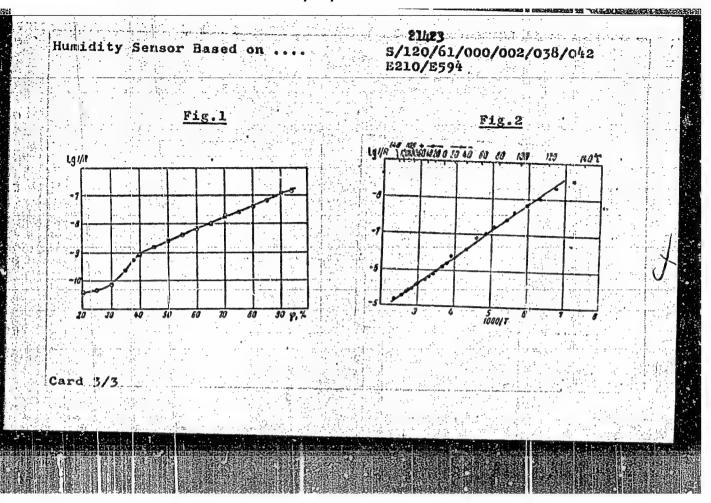
[ Abstractor's Note: This is a condensed translation.]
SUBMITTED: May 18, 1960
Card 2/3

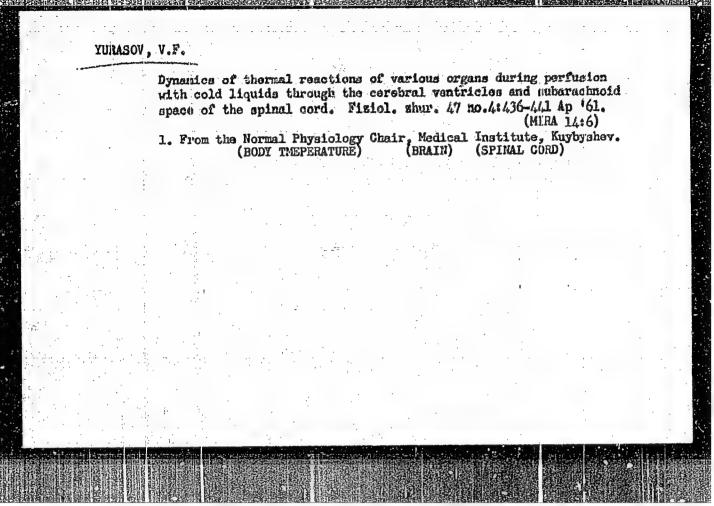
APPROVED FOR RELEASE: 09/19/2001

CIA-RDP86-00513R001963210001-8"

"APPROVED FOR RELEASE: 09/19/2001

CIA-RDP86-00513R001963210001-8





APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

## "APPROVED FOR RELEASE: 09/19/2001

CIA-RDP86-00513R001963210001-8

P021F

1015/1215

S/239/62/048/004/001/002

77 1140 13500 AUTHOR:

TITLE:

Yurasov, V. F

The temperature of the brain and viscera following cooling of CNS

PERIODICAL: Fiziologicheskiy zhurnal SSSR im. I. M. Sechenova, v. 48, no. 4, 1962, 413-421

TEXT: The problem of the temperature of the various parts of the brain and organs in normal conditions and after cooling of the organism is still a matter of controversy. This is the continuation of a previous study. Acute experiments were performed on 40 dogs. The direct cooling of various parts of CNS was performed by the perfusion technique through the ventricles and subarachnoidal space of the spinal cord (Golovin's method). The temperature of the liver, of muscles of the thigh, of the rectum, of the skin and of the brain at three different levels was measured every 5-10 min, with electrother mometers ЭТУ-М (ETU-M) and "Bioterm". Environmental temperature during the experiments was 18-25°C. The decrease in the temperature is most rapid in the cortex and slowest at the lowest levels of the brain, regardless of the site of cooling of CNS. On the other hand, it was observed that the dynamics of the thermal responses of the viscera and the brain depended on the site of cooling of CNS, although the reaction varied even following cooling of the same site. The sectal temperature did not reflect the degree of hypothermia, parti-

Card 1/2

The temperature of the brain and...

S/239/62/048/004/001/002 I015/I215

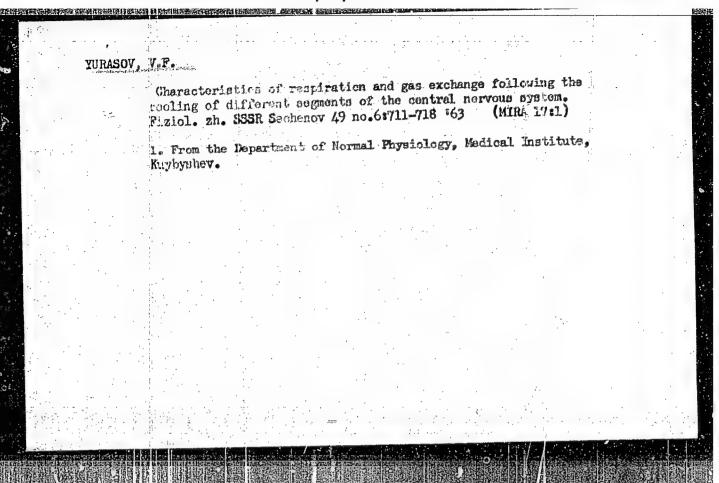
cularly that of the brain. The thermoregulation is performed by the midbrain and is affected by the corrigating effect of the cortex. The perfusion technique of Golovin enables one to perform local cooling of various parts of CNS. There are 4 figures and 3 tables.

ASSOCIATION: Kafedra normal'noy fiziologii Meditsinskogo instituta, Kuybyshev. (Chair of Normal

Physiology, Institute of Medicine, Kuybyshev)

SUBMITTEI): February 14, 1961

Card 2/2



VSEKHSYVATSKIY, Sergey Konstantinovich [Vsekhsvists\*kyi, S.K.], prof.;

KAZTURINSKIY, V.V. [Eszintyns\*kyi, V.V.], red.; [IUrasov, V.G.]

[Urasov, V.F.], otv. za vypusk

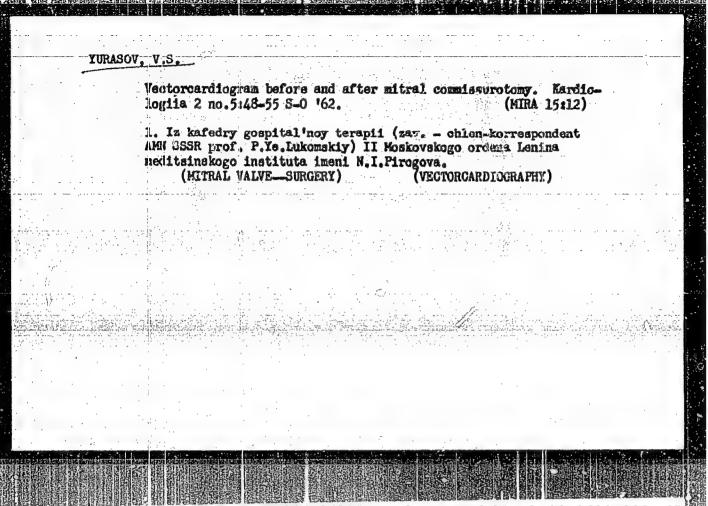
[Contemporary science on the origin and evolution of celestial bodies; data for lectures] Suchasna nauka pro pokhodzbannia i rosvytok nebennykh til; materialy do lektsii. Kyiv, 1958.

24 p. (Tovarystvo dlia poshyrennia politychnykh i naukovykh znan\* Ukrains\*koi RSE. Ser.10, no.20).

(MIRA 14:1)

(Cosmogony)

APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

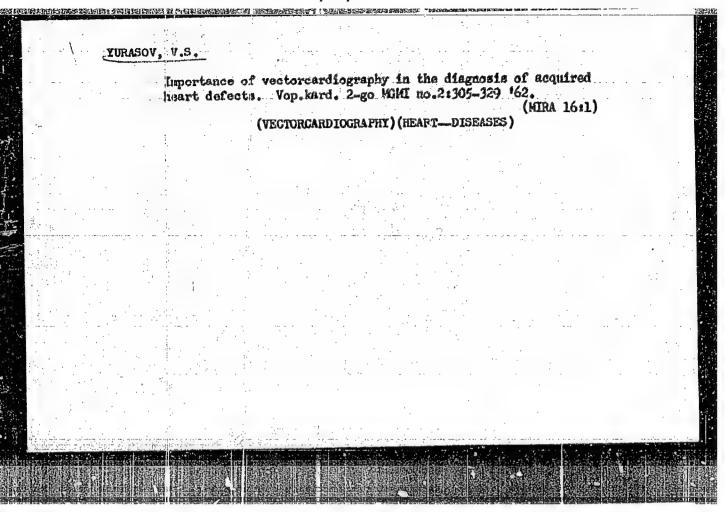


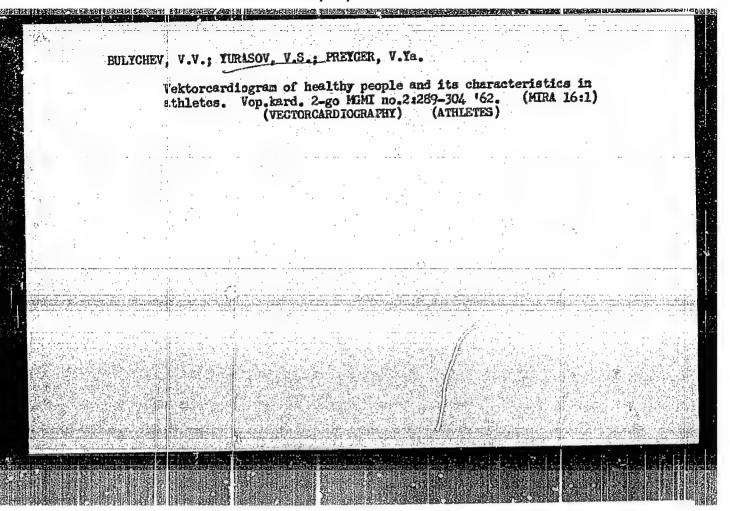
YURASOV, V. S.; BULYCHEV, V. V.; FREIGER, V. Ya.

The vectorcardiogram of healthy subjects. Cor vasa 4 no.2:114-124 '62.

1. The Department of Hospital Therapy of the II Moscow Medical Institute (Pirogov Institute), Moscow.

(VECTORCARDIOGRAPHY)





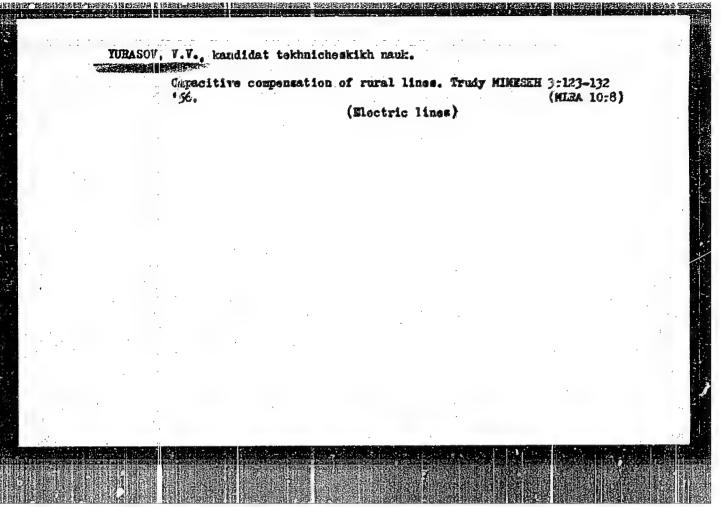
APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

SOLOVIYEV, V.V.; AKIMOV, Yu.I.; ORLOV, L.L.; TURASOV, V.S.

Diagnosis of tricuspid stenosis. Kardiologiia 5 no.2135-43
(63

163

1. Iz gospital'noy terapevticheskoy kliniki (dir. - chlenkorrespondent ANW SSSR prof. P.Ve. Lukomskiy) II Moskovskogo meditsinskogo instituta imeni N.I.Pirogova.

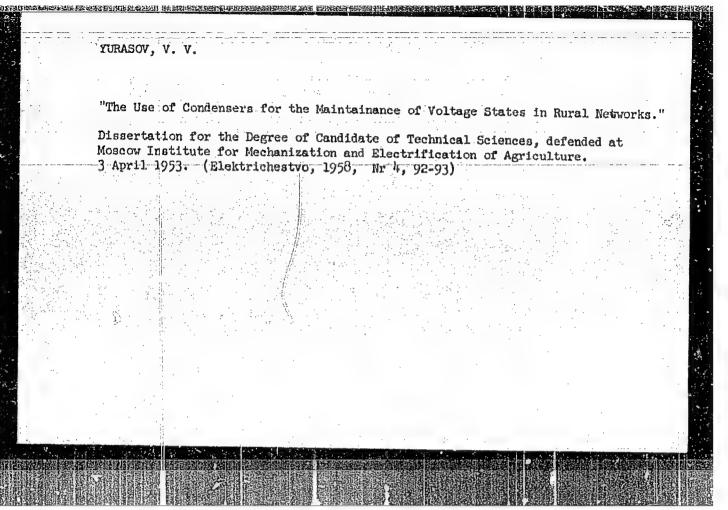


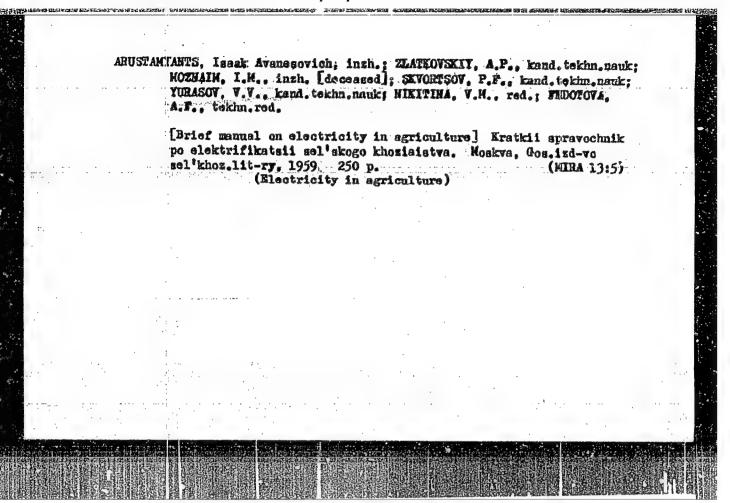
APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

YUBASOV ... kandidat tekhnicheskikh nauk. PRONNIKOVA, M.I., kandidat tekhnicheskikh nauk; SERGOVANTSEV, V.T., kandidat tekhnicheskikh nauk; SLEPYAN, Ya.Yu., kandidat tekhnicheskikh nauk, dotsent (Minsk)

"Outages and protection against them in agricultural power networks."
V.IU. Gesson. Reviewed by V.V. IUrasov and others. Elektricheatvo no.10:93-95 0 '56. (NLRA 9:11)

(Electric engineering) (Gessen, V.IU.)



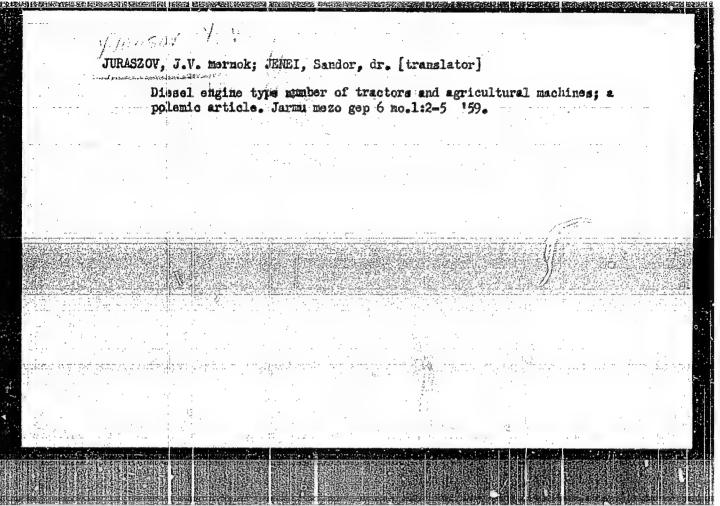


 inecessary department on recommendation and an experience of the comment of the c

SERGOVANTSEV, V.T., kand.tekhn.nauk; TURASOV, V.V., kand.tekhn.nauk;
ALUKER, Sh.N., kand.tekhn.nauk; AMERIANOV, V.N., doktor tekhn.
nauk; ASTAP'YEV, B.H., kand.tekhn.nauk; BUDZKO, I.A., akadenik;
EYSTRITSKIY, D.N., kand.tekhn.nauk; VEYALIS, B.S., kand.tekhn.
nauk; GIRSHEERO, V.V., inzh.; GORSHKOV, Ye.M., inzh.; GRICHEVSKIY, E.Ya., inzh.; ZAKHARIN, A.G., doktor tekhn.nauk;
ZLATKOVSKIY, A.P., kand.tekhn.nauk; IOSIPYAN, S.G., inzh.;
ITSKCVICH, A.M., dotsent; KAUFMAN, B.M., inzh.; KVITKO, M.N.,
inzh.; KORSHUNOV, A.P., inzh.; LEVIN, M.S., kand.tekhn.nauk;
LOBAHOV, V.H., dotsent; LITVINENKO, A.F., inzh.; MERKELOV,
G.F., inzh.; PIEKHAVKA, P.Ya., kand.tekhn.nauk; PRONNIKOVA,
M.I., kand.tekhn.nauk; SMIRNOV, B.V., kand.tekhn.nauk; FATYU—
SHENKO, S.G., inzh.; KHODNEV, V.V., inzh.; SHCHATS, Ye.L.,
kand.tekhn.nauk; SILIN, V.S., red.; SMELYANSKIY, V.A., red.;
BALLOD, A.I., tekhn.red.; SMIRNOVA, Ye.A., tekhn.red.

[Handbook pertaining to the production and distribution of electricity in agriculture] Spravochnik po proizvodstvu i raspredeleniu elektricheskoi energii v sel'skom khoziaistve. Koskva, Gos.isd-vo sel'shos.lit-ry, 1959. 900 p. (MIRA 13:2)

1. Vsesoyuznaya akademiya seliskokhozyaystvennykh nauk imeni V.I.Lenina (for Budzko). (Rural electrification)

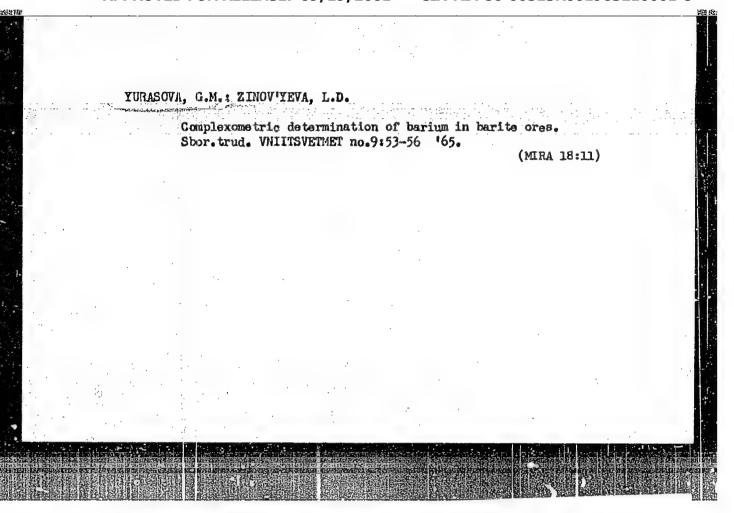


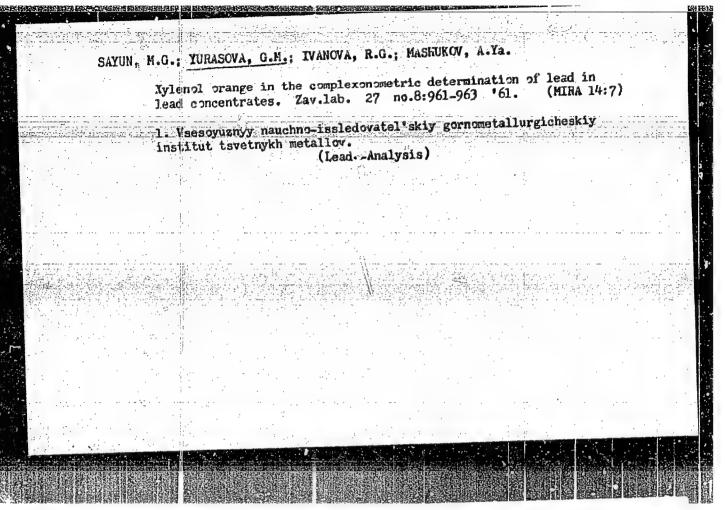
APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

BERZIN, A.A., inzh.; BORODIN, I.F., kand. tekhn. nauk; LUKOVNIKOV, A.V., kand. tekhn. nauk; PROUNIKOVA, M.I., kand. tekhn. nauk; SERGOVANTSEV, V.T., kand. tekhn. nauk; YURASOV, V.V., kand. tekhn. nauk; BURGUCHEV, S.A., zasl. deyatel nauki i tekhniki RSFSR doktor tekhn. nauk, prof., red.; NIKITINA, V.I., red.; SOLODENIKOVA, G.A., red.; SOKOLOVA, N.N., tekhn. red.

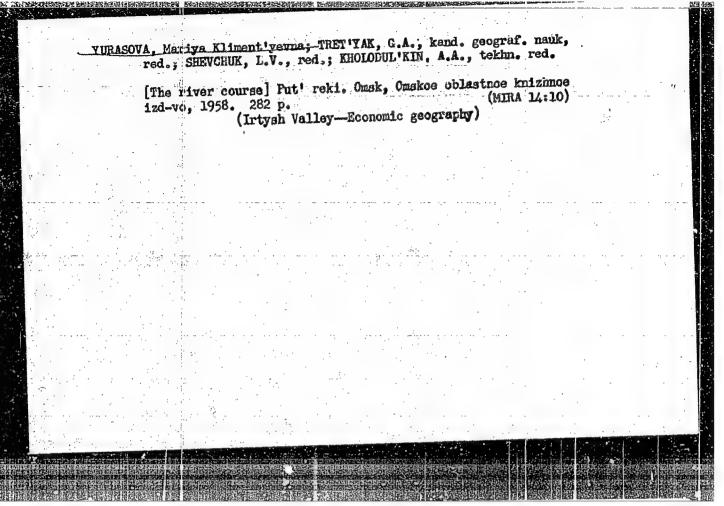
[Course on elelctric power plants, substations, and power systems] Praktikum po elektricheskim stantsiiam, podstantsiiam i sistemam. [By] A.A.Berzin i dr. Moskva, Sel'khozizdat, 1963. 303 p. (MIRA 16:12)

(Electric power plants)
(Electric power distribution)

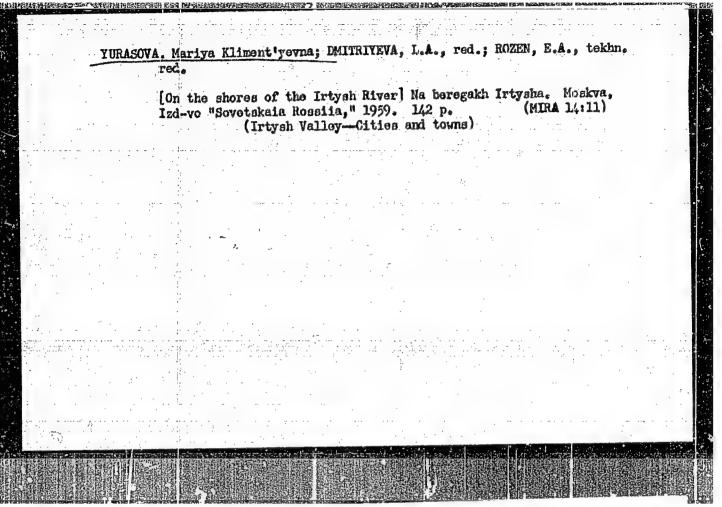




APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"



APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"



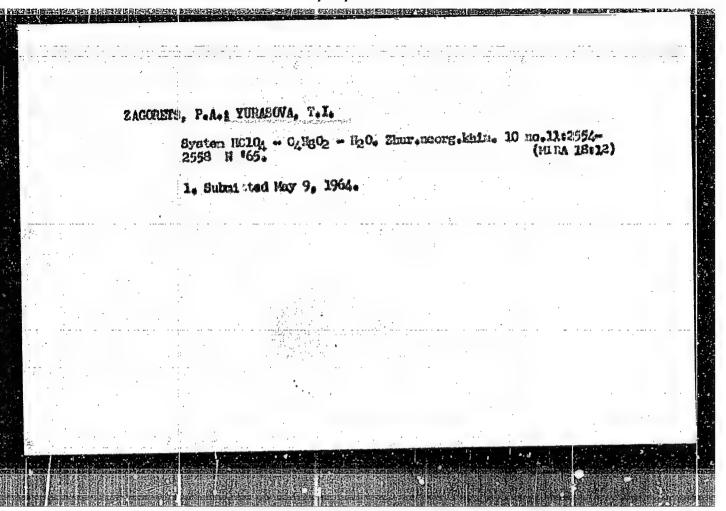
GARANTH, N.P., red.; LASHEVICH, V.I., red.; SURIKOV, N.I., red.; URAZAXEV,
A.K., red.; FISENKO, V.A., red.; YURASOVE, M.K., red.; MEL'NIKOV,
V.I., tekhm. red.

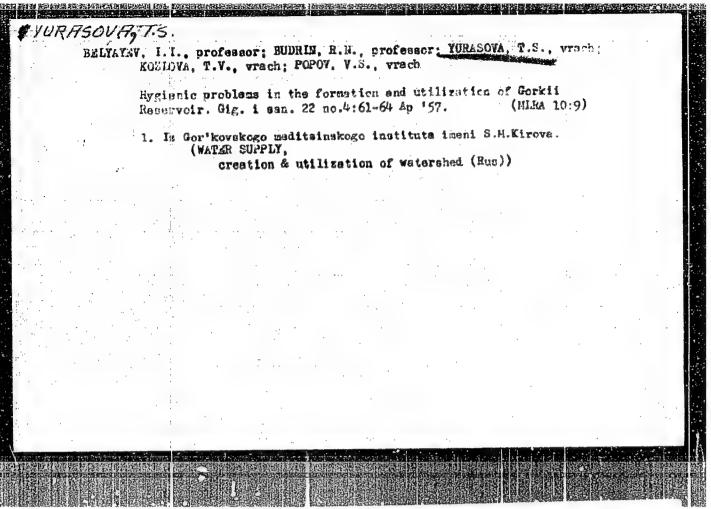
[Handbook and guids to the Irtysh and the lower part of the Ob!
Vallky] Putevoditel'-spravochnik po Irtyshu i Nizimei Obi, Omsk.,
Omskee knizhnoe izd-vo, 1960. 156 p.

(MIRA 14:10)

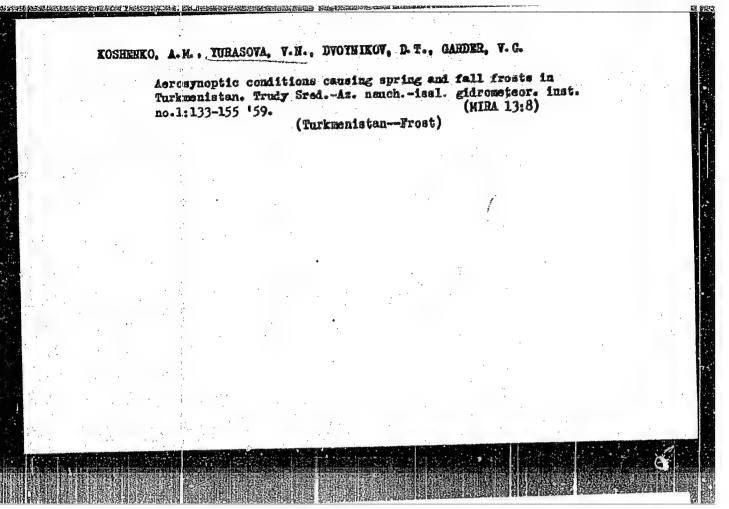
1. Irtyshskoye otdeleniye nauchno-tekhnichaskogo obshchastva vednogo transporta (for all except Yurasova, Mel'nikov).

(Irtysh Valley-Guidsbooks) (Ob' Valley-Guidsbooks)





APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

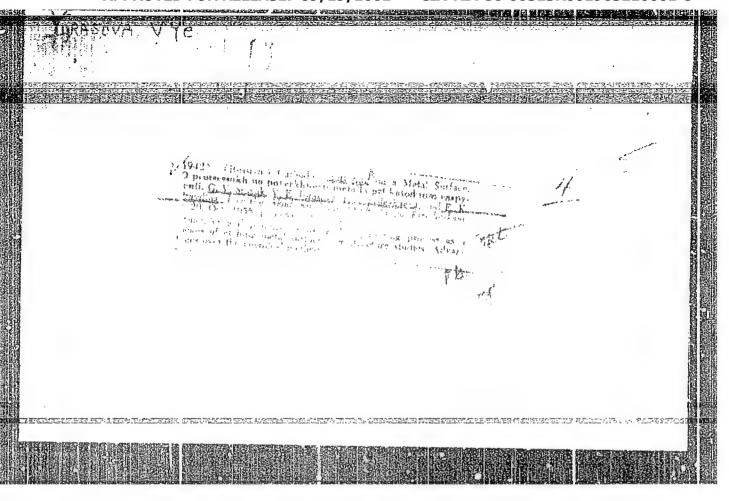


APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

YURASOVA, V.N.; KOSHEHKO. A.M.; BEZUGLOVA, V.A.

"Garmsil's" in Turkmenia. Trudy Sred.-Az.nauch.-issl.gidrometeor.
inst. no. 8:109-124, 163.

(MIRA 17:5)



JUANSOUN, V. YF.

120-2-29/37

AUTHOR: Spivak, G. V., Yurasova, V. Ye., Kushnir, F. F.

Prilezhayeva, I. N.

TITLE: Installation for metal etching by means of Ion Bombardment

(Watanovka dlya Travleniya Metallov Ionnoy Bombard-

irovkov (UIT-1)).

PERIODICAL: Pribory i Tekhnika Eksperimenta, 1957, No. 2,

pp. 105 - 110 (USSR).

ABSTRACT: Cathode sputtering has lately been widely applied to structure investigation of metals, alloys and dielectrics (Ref. 1). Its advantages compared with chemical plating have been discussed in Reference 2. Technical details of such installations have been described in References 3 and 4. In the present article the authors give the description of the UIT-1 (YMT-1) installation, thought to be much more efficient than the existing ones, mainly because of the availability of necessary conditions for plating at high temperatures. Similarly to the installation described in Reference 3, the UIT-1 (YMT-1) permits accelerated sputtering of a particular sample under forced regimes at high potentials and, similarly to that described in Reference 4, permits evaporation in a gaseous stream. Compared with other types, UIT-1 (YMT-1) has the following advantages. It permits simultaneous sputtering of three

Installation for Metal Etching by Means of Ion Bombardment.

samples (as compared with one in the installation described in References 3 and 4); this enables rapid evaluation of the best conditions for ion plating. A special arrangement for inserting the heated sample is provided, enabling the temperature to be monitored. The temperature may be varied between 100 and 700°C. It is also possible to plate already plated samples with deposits of quartz or metal without introducing air under the bell-jar thus preventing oxidisation of samples. The general view of the installation is given in Figure 1. It consists of a vacuum system (Fig. 2) and power supplies (Fig. 3). The apparatus for simultaneous plating of three samples is shown in Figure 4. Their shape may be arbitrary, with the maximum dimension of the surface to be plated of 20 x 20mm. For accelerated etching at temperatures near room temperature a special insert is provided at the apex of the glass bell-jar (Fig. 6). It is stressed that UIT-1 processes and a swift change from one operation to another, may begin one minute after the finish of sputtering; changing of sputtered samples takes no more than 15 minutes.

Installation for Metal Etching by Means of Ion Bombardment.

The analysis of the ion bombardment etching and of the applicability of the cathode sputterer to the analysis of the grain boundaries and of the surface relief structures of metals and alloys have been discussed in Reference 2. The following have co-operated with the authors in the design of the device: I.P. Bulanova, A.I. Klenova, A.I. Krokhina, N.A. Pereverzev, V.V. Potekhin and T.F. Filippova. Four photographs and three schematic diagrams are given. There are 5 references, 3 of which

SUBMITTED: December, 25, 1956.

ASSOCIATION: Faculty of Physics of the Moscow State University imeni M. V. Lomonosov. (Fizicheskiy Fakul'tet MGU im

AVAILABLE: Library of Congress.

Card 3/3

YURASOVA, V. YE

AUTHOR: Yurasova, V. Ye.

70-6-10/12

TITLE:

The Formation of Oriented Figures in the Ionic Bombardment of Metals (Obrazovaniye orientirovannykh figur pri ionnoy bombardirovke metallov)

PERIODICAL: Kristallografiya, 1957, Vol.2, No.6, pp. 770 - 775 (USSR).

ABSTRACT: The advantages of cathodic sputtering as a method obtaining oriented figures on the surfaces of metals are mentioned and conditions for the best results are indicated. Slip planes in single crystals can be detected. The mechanism of the process is discussed. The advantages over chemical etching are: there is no need to choose a suitable etch for each metal. o Sathodic sputtering can be used at any temperature from to 0.6 of the melting temperature of the metal. Strains can 20 therefore be removed if required. 3) After cathodic sputtering the surface of the metal is not covered with a layer of oxide and therefore the specimen is suitable for further electron microscopic examination. 4) By changing the kinds of ions used and the voltage and current regimes the depth of the etching can be controlled. To find the best conditions the 513 face of an aluminium single crystal was subjected to bombardment with neon ions. The voltage was 2 000 across the tube at a current

70-6-10/12

The Formation of Oriented Figures in the Lonic Bombardment of Metals.

density of 1.2 mA/cm² and a pressure of 10-2 mm Hg. Bombardment lasted 3 hours. Flats corresponding to the 110 planes were developed. (These have the greatest reticular density). After 10 hours the pattern lost its sharpness. Further tests suggested that the conditions quoted are optimum except that the pressure should be 10-1 mm Hg. Conditions for a range of metals are quoted in datail. On crystals of Cd slip planes are disclosed by bembardment. Regularities in the behaviour of various metals under this glow discharge are found: 1) Certain metals, for example, Al, shew oriented pits of one form or another and oriented hillocks are not found (when there is a net loss of material from the cathode). 2) On the closest packed planes of certain metals pits are formed and on others hillocks. On the OOOl planes of Bi hexagonal raised regions are formed but on the OOOl of Zn hexagonal pits appear. 3) Under certain conditions pits and hillocks may be produced simultaneously, for Cd, for example. Various theories of the process are discussed but mone is found very satisfactory; besides the evaporation of atoms there is surface diffusion and the re-deposition of material on the surface to be considered.

Acknowledgments to A.V. Shubnikov, G.V. Spivak and V.R. Regel'. There are 6 figures, 1 table and 10 references, 4 of which are

The Formation of Oriented Figures in the Ionic Bombardment of Metals.

ASSOCIATION: Moscow State University (Moskovskiy Gosudarstvennyy Universitet im. M.V. Lomonosova)

February 21, 1957.

AVAILABLE: Library of Congress.

Card 3/3

APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

SPIVAK, G. V., MIRASOVA, V. Ye., bind SHISHKINA, Ye. I.

(Moscow Univ.)

"An Original Method of Exposure of Magnetic Heterogeneity in Metal."

paper presented at the All-Union meeting on Magnetic Structure of Ferromagnetics June 1958, in Breanoyarsk. Meeting appreciated by Inst. of Physics, Acad. Soi. USSR, and Comm. for Magnetism, Dept Phys-Math Soi, AS USSR,

Translation from: Referativnyy zhurnal, Metallurgiya, 1958, Nr. 10, p 144 (USSR)

AUTHOR: Yurasoya, V. Ye...

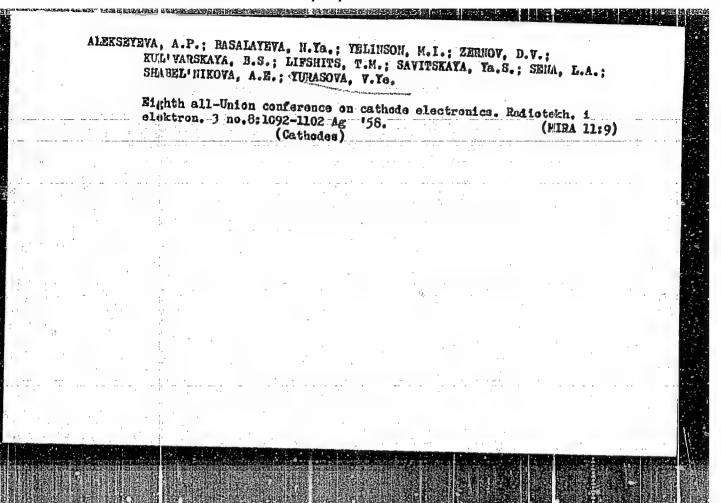
TITLE: On the Processes of Cathodic Atomization of Single Crystals and Polycrystals of Metals (O protsessakh pri katodnom raspylenii metallicheskikh mono- i polikristallov)

ABSTRACT: Bibliographic entry on the author's dissertation for the degree of Candidate of Physical-Mathematical Sciences, presented to (FMGU (Moscow State Univers, y), Moscow, 1958

ASSOCIATION: MGU (Moscow State University), Moscow

1. Single crystals---Processing 2. Metal crystals---Processing

Card 1/1



Yurasova. V. JUV/57-28-3-16/33 index medical responsibility of the Micro-Relief of the Destroyed Metal Surface ( ovremenning teorii katodnogo raspyleniya i mikrorel'yef razrushayomoy poverkhnosti metalla) Zhurnal tekhnicheskoy fiziki, 1958, Nr 9, pp. 1966-1970 (USSR) FERIODICAL: First a chort curvey covering the modern theories of cathode AMSTRACT: disintegration is given. The problem is approached whether a by encourse could be established between the disintegrationocoefficient and the crystallographical orientation with the target is irradiated by fast ions. A copper monocrystal was investigated for information bearing on this problem, its cubic suface being used as a target for crypton ions generated in a plasma with a high density and low pressure. An additional ionization is caused by the emission of the oxide cathode. The evidence found was that the deposit from the disintegrated substance does not follow a cosine distribution, but that it consists of individual specks. The ions were accelerated through about 1000 to 4000 Volts. Additional experiments in which a copper nonocrystal was vaporized (at about 950 C) showed that the deposit distribution from an evaporation of a (100) sur-

Modern Theories of Julio te Disintegration, and SOV/57-23-9-16/33 Metal Surface

face follows a cosine curve independently from the initial state of the surface. Then, however, it is etched by means of an ion bomberdment slucys a typical pattern is established. This fact indicates an escential difference between the mechan-isms of cuthode disintegration and of vaporization. Moreover, it appears that the directional emission of the particles caused by an ion bombardment cannot be explained by secondary aurface phenomena. The predominant disintegration the substruce along certain simple crystallographic orientations is apparently caused by the mechanism of ion etching. There is every indication that the existing theories of cuthode disintegration offer no means for the explanation of the levaporation versus orientation function at high velocities obtained in this work. G. M. Protopopova, who is preparing for her diploma Lasisted in the work. A. P. Komar and N. D. Horgulia made substantial contributions to it. It was supervised by C. V. Spivek. There are 4 figures and 11 references, 4 or which are Soviet.

Card 2.3

Moscow State Univ

SOV/126-7-6-14/24 AUTHORS: Spivak, G.V., Yurasova, V.Ye., Klenova, A.I. and Vlasova, T.A On the Exposure of the Structure of Metals by Gas Ion TITLE: Bombardment PERIODICAL: Fizika metallov i metallovedeniye, 1959, Vol 7, Nr 6, pp 893-898 (USSR) ABSTRACT: In order to show the possibilities of revealing the metal structure of a heated material by a cathode sputtering method, the authors investigated several characteristic alloys. Atomizing of the specimens at a definite temperature was carried out in the apparatus for the ionic etching of metals UIT-1 used by Spivak et al. (Ref 3), in which there is a special device for heating the specimen (from 100 to 700°C) and for measuring its temperature. Sheet specimens of an Al-Mg alloy (6% Mg) were submitted to ion bombardment at 500°C. Cathode sputtering (together with selective evaporation which takes place at such a temperature) reveals the grain boundaries of an Al-Mg alloy (6.5% Mg) heated to 500°C. In Fig 1b the surface of this alloy, etched with meon ions at 280°C and in Fig la the structure of the same alloy revealed by cathode sputtering at 500°C are shown. From

APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

On the Exposure of the Structure of Metals by Gas Ion Bombardment

comparison of these photographs it can be seen that at 500°C the grain size of the alloy is considerably coarser and the grain boundaries are finer. Apart from this alloy, etching of specimens of steel YalT was with the apparatus UIT-1. In this case, chromium carbides precipitated along the grain boundaries at 500°C. The presence of chromium carbides after chemical etching is only apparent from the holes where the carbides were attacked. By means of ionic etching at 600°C the chromium carbide precipitates along the grain boundaries could be seen in the form of small dark spheres of approximately 1 to 2µ diameter. A photograph of the surface of steel YalT specimens etched at 600°C and subsequently cooled is shown in Fig 2. In Fig 3 ferrite and austenite grains revealed as a result of cathode sputtering of the steel YalT are shown. In Fig 4 the structure of pure aluminium sheet is shown (a - after chemical etching; b - after etching by ion bombardment). The extent to which the metal structure is revealed can be best judged by the depth of etching of the intergranular boundary. Therefore, in order to select the correct

Card 2/5

On the Exposure of the Structure of Metals by Gas Ion Bombardment sputtering treatment, the dependence of the depth of metal grain boundary etching on the parameters of the gas discharge during simultaneous sputtering was studied. The depth of the boundaries was measured by a stemoscopic method. A quartz print was taken from the atomized surface of the specimen and a precise portion of this print was photographed in the electron microscope UEM-100 under an angle of +6 and -6° relative to the optical axis, The storeo-couples obtained (Figs 5a and b) were studied with the precision stersometer SM-3, which gives the volume effect. In order to obtain more reliable results, the atomizing of the grain boundary was studied in neon and in air for several types of technical copper with two different instruments. Ionic etching of the specimens was carried out initially in a glass tube. The investigated specimen was used as the cathode in the tube. During atomizing, the specimen temperature was kept constant by cooling it with water. The dependence of the depth of etching of the grain boundary on the potential difference between the cathode and arode during atomizing in neon Card: 3/5 was determined. The density of the discharging current

APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

On the Exposure of the Structure of Metals by Gas Ion Bombardment was kept constant  $(j = 10 \text{ mA/cm}^2)$ . measurements carried out are shown by the curve 3 in Fig 6. The dependence of the depth of etching of the grain boundaries on the density of the discharging current was studied on two types of specimens which were cut out from technical copper of somewhat different compositions. The density of the discharging current varied between 5 and 15 mA/cm2; the potential difference between the electrodes The dependence of the depth of etching of the The specimen was atomized for grain boundaries on the density of the discharging current was found to be linear (Fig 7). From an analysis of the curves obtained for the dependence of the depth of etching of the intergranular metal boundaries on the density of the discharging current and on the potential difference between the electrodes it is possible to arrive at the following conclusions: there is no advantage in raising the potential difference between the cathode and the anode above 8-9 kw to accelerate revealing the metal structure. It is better for the density of the discharging current to be increased. The greatest permissible density of the

CIA-RDP86-00513R00196321UUU1-

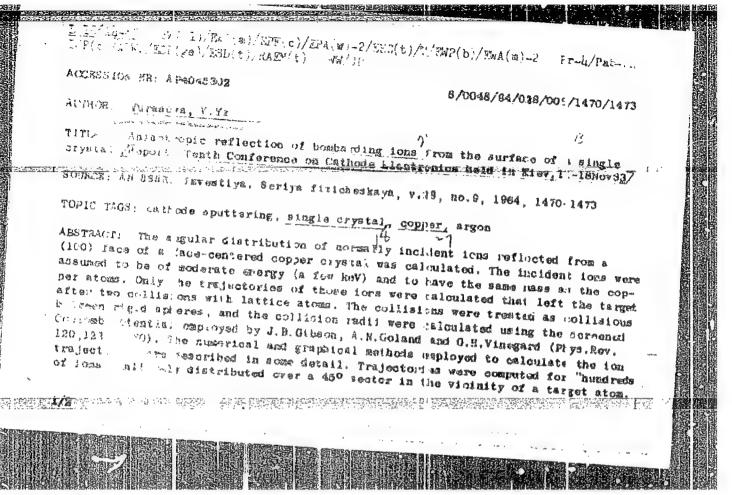
On the Exposure of the Structure of Metals by Gas Ion Bombardment

discharging current in cathode sputtering of metals is determined by the intensity of the cooling rate of the specimen. In the case under consideration, in which the atomized specimens were cooled in a mixture of dry ice and alcohol, a current density exceeding 15 mA/cm2 should not be used. However, at a more intensive cooling rate, greater discharging currents can be used. The best operating conditions for atomizing technical copper are:  $j = 10 \text{ mA/cm}^2$ , u = 9 kW, t = 5 min,  $p = 5 \times 10^{-2} \text{ mm}$  Hg col. There are 7 figures and 7 references, 5 of which are Soviet, 1 English and 1 German.

ASSOCIATION: Moskovskiy gosudarstvennyy universitet imeni M. V. Lomonosova (Moscow State University imeni M.V. Lomonosov)

SUBMITTED: January 25, 1957 (Initially) November 12, 1957 (After revision)

Card 5/5



1 106111-05 ACCESSION NR: AP4045302 It was found that minimum numbers of particles are reflected in the [110] and [100] directions, and maximum numbers in the direct was oil loose packing lying between these axes. There are in all eight directions of maximum reflections; tress are inclined at 20° t) the normal ([130] axis; and are distributed at 410 intervals in asiguth. Simila: culculations were performed for the reflection of 2 ke/ argon lone from a copper c yetal. The results were qualitatively similar to those for ions equal in case to the target atom, and are reported to be in good agreement with the experimental data of V. Yw. Yurasova, V.A. Brahezinskiy and G.M. Ivanov (Zhur. oksp. i teor, fiz.46, No. 8, 1964). Orig.art.bas: 5 foraulas and 4 figures. ASSOCIATION: Fisionskip fabriling Mossover to complete very complete to (Fornice Disparts set / Moncos Rus & Calverry OO : CETTIMBUR SUB CODE: NC.88 THEL! OO HE RE' SCV: 003 THERE OF 3/2

AUTEORS: Yurasova, V. Ye., Spivak, G. wahnir, P. P. SOV/48-23-6-19/28 Hethods for the Development of the Structure of Metals and TITLE: Alloys by Ion-bombardment (Metodika vyyavleniya struktury metallov PERIODICAL: Izvestiya Akademii nauk SSSR. Seriya fizioheskaya, 1959, Vol 23, Nr 6, pp 744 - 749 (USSR) ABSTRACT: In the first part of the present paper ion-etching of the granular boundaries and of the structural composition of the alloys are investigated within a large temperature interval. First; the advantages of cathodic spraying as against chemical etching and thermal evaporation in a vacuum are pointed out. One of the most important advantages is the possibility of carrying out structural investigations within a large temperature interval. For visual investigation and for photographing a special attachment was constructed (Fig 1). Seven pictures are then shown of aluminum bronze (Figs 2,3), which were taken after various forms of thermal treatment by ion-spraying and cathodic spraying and 350-fold enlargement. The first series of pictures Card 1/2

Methods for the Development of the Structure of Metals and 50V/48-23-6-19/28

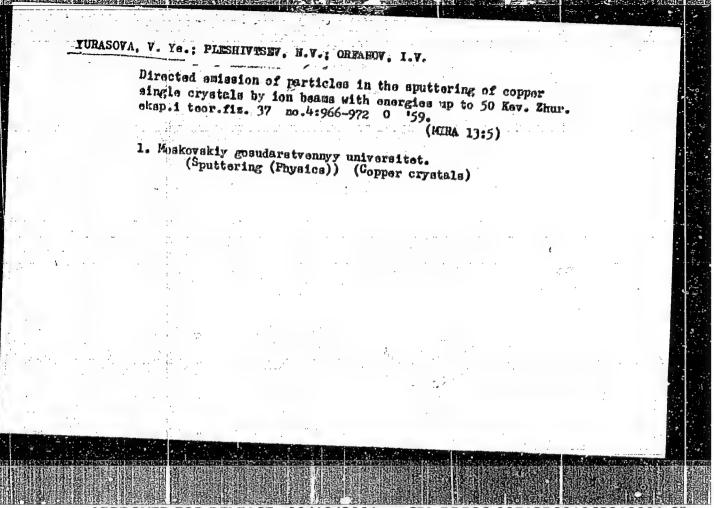
distinctly show, the formation of the martensite structure in the three ranges of temperature, whereas the second series shows the structural grains at various temperatures. In the sccond part of the paper the destruction of the surface of the structural grains of polycrystals or of monocrystals by ionhombardment is investigated. First, the fact is pointed out that by the investigation of the symmetric indentations our knowledge of the mechanism of cathode-spraying has been extended, and that new possibilities of applying ion bombardment may now be found. It follows from the pictures (Fig 5) that the symmetry of orientated indentations agrees with the orientation of the surface of a monocrystal. In the following, the influence exercised by the increase of ion energy is investigated and explained on the basis of figure 5. The sults obtained make it possible to assume that the orientated indentations may form in the course of ion-etching. There are t ligures and 7 references, 5 of which

ASSOCIATION,

dird 2/2

APPROVED FOR RELEASE: 09/19/2001

CIA-RDP86-00513R001963210001-8"



APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

PHASE I BOOK EXPLOITATION SOV/5526

Vascoyuznoyo soveshohaniye po magnitnoy strukture forromagnetikov,
Krasnoyarsk, 1956.

Magnitnaya struktura forromagnetikov; materialy Vascoyuznogo
soveshohaniya, 10 - 16 junya 1958 g., Krasnoyarsk (Magnetic
Conference on the Magnetic Structure of Ferromagnetic Substances,
Siturcture of Ferromagnetic Substances, Materials of the All-Union
Cenference on the Magnetic Structure of Ferromagnetic Substances,
Siturcture of Magnetic Structure of Ferromagnetic Substances,
Siturcture of All SSSR, 1960. 249 p. Errata slip insorted.

Sponsoring Agency: Akademiya nauk SSSR. Institut fiziki Sibirskogo
offul.

Sponsoring Agency: Akademiya nauk SSSR. Institut fiziki Sibirskogo
offul.

Reap. Ed.: L. V. Kirenskiy, Doctor of Fhysical and Mathematical
Sciences; Ed.: R. L. Dudnik; Tech. Ed.: A. F. Mazurova.

PURPOSE: This collection of articles is intended for researchers in
ferromagnetism and for metal scientists.

Card 1/11

									1		
						· · · · · · · · · · · · · · · · · · ·		71			<u> </u>
	Magnetic:	Structure	(Cont.)								15. 12 S
	COVERAGE:	The coll	and an				/5526	÷ :	-		
	at the	All-Union	ction conta Conference ces, held in	on the Ma	ientific : metic St	articles	presented		. :		
	terial	containe d	lata am bb-		THE THE OWN	14 1420.	The man		:		
	mannati	46 E1817 D	innual -1	4.4	a ox me ente	in reint	ion to		; 4		1, 1
	Cording	to the Re	marrama 41-	- 10 1 CB1	see' wor a	cemperatui	d. An-		:		
	Bubseru	ently alon	antida		WITCH THE	ine 1930 i	. Won				
	individ	No perso ual articl	nalities are	mentione	d. Refer	ences acc	ompany	:			
. :	TABLE OF C					•			i		
			·								
	Ronewand							' .		, .	
	Foreword						3				
· ·	Shur, Ya.	S. [Insti	tut fiziki m	etallov A	n sssr -	Institute	3 of		*	,	
	Shur, Ya.	S. [Insti- Metals, As of Ferroma	tut fiziki m S USSR, Sver znetic Subst	etallov A dlovskl. ances	N SSSR - On the M	Institute agnetic	3 or				
:	Shur, Ya.	3. [Insti Metals, As of Ferromas	tut fiziki m 3 USSR, Sver metic Subst	etallov A dlovsk], ances	N SSSR - On the M	Institute agnetic	3 or 5				
	Shur, Ya. 1 Physics of Structure of	3. [Insti Metals, As of Ferromag	tut fiziki m 3 USSR, Sver metic Subst	etallov A dlovsk]. ances	N SSSR - On the M	Institute agnetic	3 or 5				
	Shur, Ya. 1 Physics of Structure of	S. [Insti	tut fiziki m S USSR, Sver gnetic Subst	etallov A dlovsk]. ances	N SSSR - On the M	Institute agnetic	3 of				
	Shur, Ya. 1 Physics of Structure of	S. [Insti Metals, As of Ferromas	tut fiziki m S USSR, Sver gnetic Subst	etallov A dlovsk]. ances	N SSSR - On the M	Institute agnetic	3 of 5				
	Shur, Ya. 1 Physics of Structure of	S. [Insti	tut fiziki m S USSR, Sver metic Subst	etallov A dlovsk]. ances	N SSSR - On the M	Institute agnetic	3 or 5				
	Shur, Ya. 1 Physics of Structure of	S. [Insti	tut fiziki m 3 USSR, Sver znetic Subst	etallov A dlovsk]. ances	N SSSR - On the M	Institute agnetic	3 of 5				
	Shur, Ya. 1 Physics of Structure of	S. [Insti	tut fiziki m S USSR, Sver gnetic Subst	etallov A dlovsk]. ances	N SSSR - On the M	Institute	3 of -5				
	Shur, Ya. 1 Physics of Structure of	S. [Insti	tut fiziki m S USSR, Sver metic Subst	etallov A dlovsk]. ances	N SSSR - On the M	Institute	3 or -5				
	Shur, Ya. 1 Physics of Structure of	S. [Insti	tut fiziki m S USSR, Sver gnetic Subst	etallov A dlovsk]. ances	N SSSR - On the M	Institute	3 of 5				
	Shur, Ya. 1 Physics of Structure of	S. [Insti	tut fiziki m S USSR, Sver metic Subst	etallov A dlovsk]. ances	N SSSR - On the M	Institute	3 of -5				

	to State of Belline State Stat
Magnotal	
Magnetic Structure (Cont.)	9011 /
on the Magnetic Properties of Ferrites	80V/5526
Dobbton it	175
Dekatyar, M. V., and N. M. Kazantseva [Physics Department the Meschwitate University]. Anomalous Temperature Department of Augustic Properties of Augustic Prope	ent of Sendence
Spivak of W and T	177
Spivak, G. V., and I. A. Pryamkova [Physics Department the Moscow State University]. Development of the Electrician of the Visual Observation of the Electricians.	of
TATALUL MEEDON FOR The M	on-
of rerromagnetic Substances	
Spivak a v v	185
[Physics Department of the Moscow State University].	
Concerning Che Method for the Detection of Magnetic	
	191
Drokin, A. I., D. A. Laptey, and R. P. Smolin [Institute	· · · ·
of Physics, Siberian Branch AS USSR, Krasnoyarsk]. Therm magnetic Hysteresis of Ferromagnetic Substances at the Polard 0/11	0-
ard 9/11	inta
是在"是"的"是"的"是"的"是"的"是"的"是"的"是"的"是"的"是"的"是"的	
[1 PROTECT OF THE TOTAL OF THE TOTAL CONTROL OF THE TOTAL CONTROL OF THE TOTAL CONTROL OF THE TOTAL CONTROL OF	

s/070/60/005/003/020/024/XX E132/E460

AUTHORS:

Yurasova, V.Ye., Pavlovskaya, E.A., Tyapunina, and Predvoditelev, A.A.

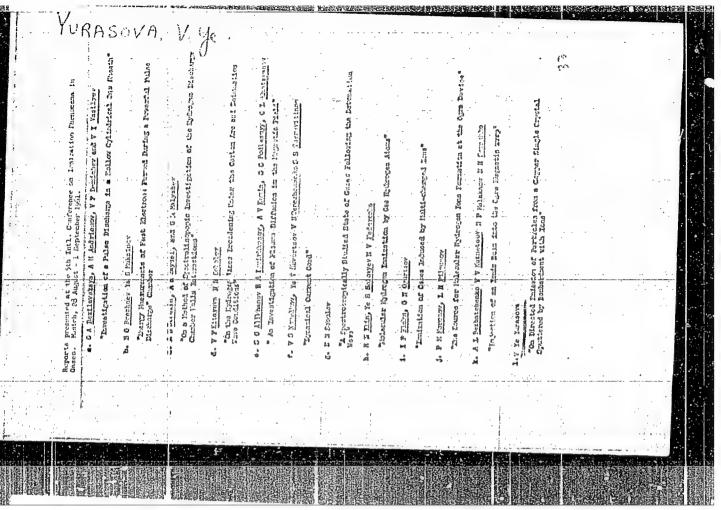
The Application of Ionic Etching For Showing Up Dislocations in Metallic Crystals

PERIODICAL: Kristallografiya, 1960, Vol.5, No.3, pp.437-440

TEXT: Etching is the most widely used method of revealing the emergence of dislocations at a crystals surface and is usually chemical or electrolytic. To show the dislocations successfully it is essential that impurities should be concentrated in them giving a Cottrell atmosphere. The method of ionic etching has been studied as it has the advantage of producing no superficial oxidation and of being usable over a wide temperature range. Dislocations are shown up by the selective sputtering of ions from the disturbed places in the lattice. Cadmium crystals have been used with zinc as the decorating impurity. Sputtering was carried out in a glow discharge in air or neon at 10-1 to 10-2 mm Hg. The best conditions were found to be: current density 20 ma/cm2, voltage 1500 to 2000, duration 20 min and pressure 10-1 mm Hg.

S/070/60/005/003/020/024/xx E132/E460 The Application of Ionic Etching for Showing Up Dislocations in Metallic Crystals Electrolytic etching of the same specimens was carried out for comparison. The results show a very close correspondence between the two methods. A particular dislocation configuration is quantitatively analysed, Acknowledgments are expressed to Professors G.V. Spivak and Ve.G. Shvidkovskiv for their interest in the work and to V.L. Indenbom for useful advice. There are 5 figures and 9 references: 4 Soviet and 5 English. ASSOCIATION: Moskovskiy gozudarstvennyy universitet in. M.V. Lomonosova (Moscow State University im. M.V.Lomonosov) SUBMITTED: September 9, 1959 Card 2/2

"APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8



APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

S/058/61/000/012/054/083 A058/A101

AUTHORS:

Spivak, G.V., Shishkina, Ye.I., Yurasova, V.Ye.

TITLE:

Concerning a method for detecting magnetic inhomogeneities

PERIODICAL:

Referativnyy zhurnal. Fizika, no. 12, 1961, 385, abstract 12E684 (v sb. "Magnitn. struktura ferromagnetikov", Novosibirsk, Sib. otd. AN

The feasibility was demonstrated of detecting magnetic inhomogeneities of the surfaces of ferromagnetics by means of chemical etching. The indicated method is based on the fact that ions in solution that have a magnetic inoment are drawn into the region with the highest magnetic-field gradient. The most effective etchants and etching conditions were found by the trial-and-error riethod. Using the described method, an electron-microscope image was obtained of charge and Mo bands, as well as an image of natural magnetic inhomogeneities in martensitic needles in steel.

[Abstracter's note: Complete translation]

N. Sedov

Card 1/1

YURASOVA, Y. Ye., SIRCTENKO, I. C., and BURHANOV, V. M.

"On the peculiarities of the anisotropy of the moncoristal cathode sputtering.

report submitted for the Colloquium CNRS on Ionic Bombardement ,National Center of Scientific Research , Bellevue, 4-8 December 1961.

#### "APPROVED FOR RELEASE: 09/19/2001 CIA-RDF

CIA-RDP86-00513R001963210001-8

24803

9,4300

S/U4B/61/025/006/003/010 B117/B212

AUTHORS:

Spivak, G. V., Kushnir, F. F., and Yurasova, V. Ye.

TITLE:

YNT-3 (UIT-3) installation for etching metals, semiconductors and dielectrics through ion bombardment

FERIODICAL:

Akademiya nauk SSSR. Izvestiya. Seriya fizicheskaya, v. 25 no. 6, 1961, 707 - 712

TEXT: The present paper has been presented at the 3<sup>rd</sup> All-Union Conference on Electron Microscopy, held in Leningrad from October 24 to 29, 1960. It describes a new model of a technical installation of type YNT-3 (UIT-3) for etching metals, semiconductors, and dielectrics through ion bombardment. The models UIT-1 and UIT-2 have been described in Refs. 1 and 2 (Spivak C. V., Yurasova V. Ye., Kushnir F. F., Prilezhayeva I. N., Pribory i tekhnika eksperim., Nº 2, 106 (1957); Yurasova V. Ye., Spivak G. V., kushnir F. F., izv. AN SSSR, Ser. fiz., 23, 744 (1959)). The UIT-3 installation is designed for the following investigations of the surface structure of materials under different conditions: 1) heating of a sputtered specimen not above 1200°C; 2) cooling of the specimen during Card 1/6

APPROVED FOR RELEASE: 09/19/2001

CIA-RDP86-00513R001963210001-8"

24803

MM-3 (UIT-3) installation.

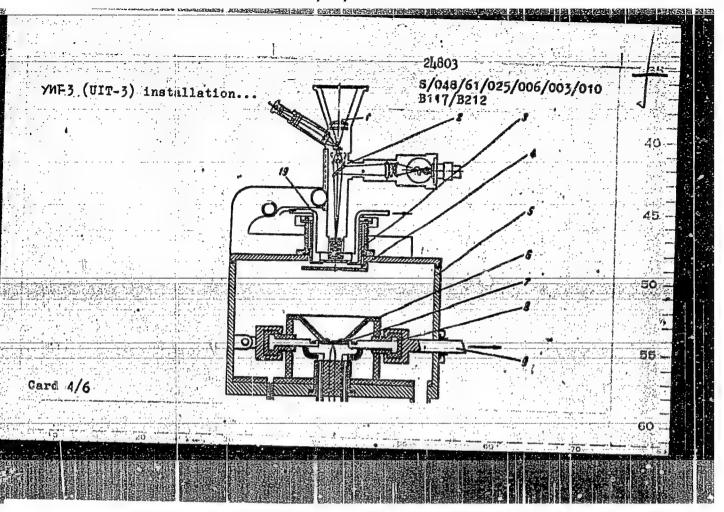
S/048/61/025/006/003/010 B117/B212

etching with running water; 3) observation of the object surface during sputtering or evaporation by using an optical system with a long focal length; 4) expansion or compression of the specimen during ionic etching or evaporation; 5) application of quartz or metal foils (necessary for the subsequent electron-optical study of the powdered surface) right after ionic etching of the apecimens. The UIT-3 installation consists of the following main components: system for generating and measuring the vacuum, feeding device, control console, device for expansion and compression of the specimens, metallographic microscope and a device to sputter and heat the specimens. The vacuum system of UIT-3 is analogous to that of UIT-1. The electric system consists of the following main components: high-tension rectifier for 10 kv and 50 ma; besting current transformer ( 7 v, 250 a) with a device to transfer the potential either to heat or evaporate the specimen; platinum-platinum-rhodium or chromel-a-umel thermo couples with a millivoltmeter for measuring the temperature of the specimen; device for measuring the vacuum and turring on the pumps; interlocks which switch off the high tension when the doors of the installation are opened. Fig. 2 shows a diagram of the UIT-3 installation. The shape of the specimens to be sputtered may be arbitrary if no load is applied. The maximum size of a Card 2/6

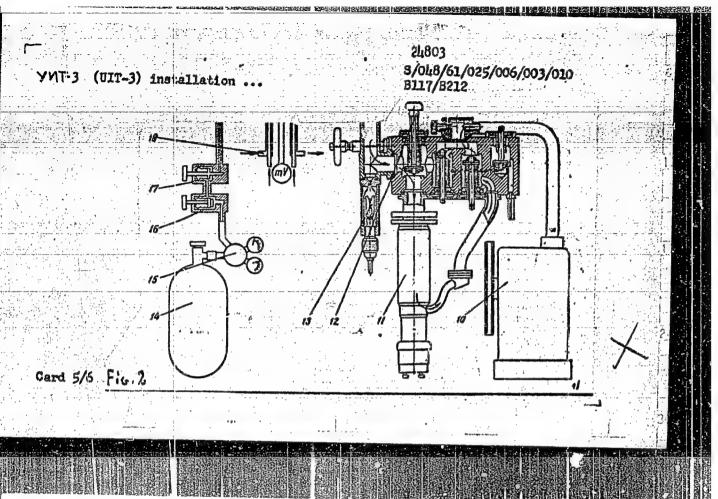
THE WAY THE WAY THE	
specimen bomb specimen is h During sputte length of 60 after the ion specimen. Th monocrystals which are obt the surface w indices of si very promisin chemical etch	installation S/048/61/025/006/003/010 B117/B212  arded with tons should not exceed 30 × 30 × 8 mm. When the leated up to 1200°C it should not be larger than 20 × 20 × 2 mm.  The specimen having a maximum cross section of 20 mm² and a single a specimen having a maximum cross section of 20 mm² and a single a specimen having a maximum cross section of 20 mm² and a single a specimen having a maximum cross section of 20 mm² and a single a specimental, or carbon foil can be put on the single at the edges of the which have the symmetry of these edges. The oriented figures, which have the symmetry of these edges. The oriented figures, here they are located, may be used to determine roughly the mplest crystal edges. The application of ionic etching seems to visualize dislocations, especially for heated specimens if the construction of the symmetry of the second seems are 4 figures and 4 references: 3
ASSOCIATION:	Fizicheskiy fakul tet Moskovskogo gos. universiteta im. M. V. Lomonosova (Division of Physics of Moscow State University
	imeni M. V. Lomonosov)
Card 3/6	

APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

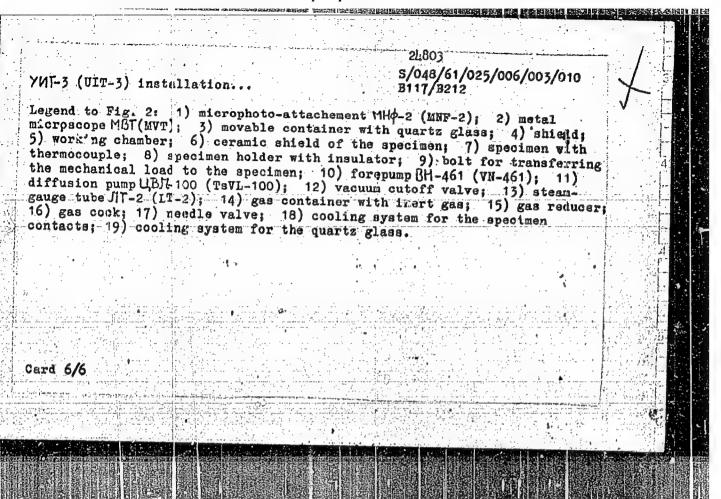
"APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8



APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"



APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"



26689 5/056/61/041/005/004/038 B104/B108

26,2340

Yurasova, V. Ye., Sirotenko, I. G.

TITLE:

AUTHORS:

Cathode sputtering of single-crystal balls

PERIODICAL:

Zhurnal eksperimental'noy i teoreticheskoy fiziki, v. 41,

no. 5(11), 1961, 1359-1364

TEXT: Cathode sputtering of single-crystal balls of copper, tungsten, chromium, cobalt, germanium, iron, and an indium-antimony alloy has been carried out in a plasma of low pressure and high density (crypton pressure w5.10-3 mm Hg). The ball-shaped specimens had a diameter of from 3 to 6 mm. During sputtering, the specimens were on a negative potential of from 1 to 10 kv. Current density was 5-7 ma/cm2, in some experiments even 13-15 ma/cm. The sputtered substances were collected on spherical or cylindrical surfaces. The direction of emission of the sputtered particles was determined. From diamond-type or face-centered cubic lattices, the substances were chiefly sputtered in the [110] and [100] directions. From body-centered cubic lattices, the substances were chiefly sputtered in the [111] and [100] directions. The precipitation Card 1/2

ROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001

26689 \$/056/61/041/005/004/038 B104/B108

Cathode sputtering of single-

spots obtained from single-crystal balls were more distinct than those obtained from sputtering of plane single crystals. The precipitation spots of substances with face-centered lattice were the clearest. The precipitation intensity of substances with diamond lattice varies from the center of the spot to its boundary nearly according to the cosine law. The precipitation intensity of substances with other lattice types decreases more rapidly from the center to the boundary. The sharpness of the precipitation spots increases with increasing sputtering coefficient, atomic number of the sputtered target, and temperature, and with decreasing lattice constant. The authors thank professor G. V. Spivak for discussions and V. M. Bukhanov for assistance in the experiments. There are 4 figures, 1 table, and 10 references: 1 Soviet and 9 non-Soviet. The 4 most recent references to English-language publications read as follows: E. B. Henschke, J. Appl. Phys., 28, 411, 1957; R. H. Silsbee, J. Appl. Phys., 28, 1348, 1957; G. H. Gibson et al., Phys. Rev., 120, 1229, 1960; G. H. Vineyard, V. L. Gibson, Bull. Am: Phys. Soc., 5, 26, 1960.

ASSOCIATION: Moskovskiy gosudarstvennyy universitet (Moscow State

University)

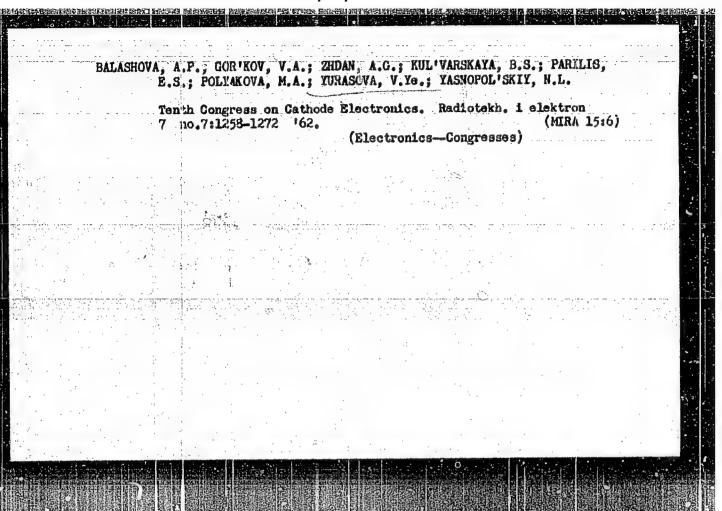
SUBMITTED: April 27, 1961

Card 2/2

YURASOVA, V.Ye.; BUKHANOV, V.M.

Anisotropy of cathode sputtering of a copper monocrystal as a function of its temperature. Kristallografiia 7 no.2:257-260 Mr-Ap '62. (MIRA 15:4)

1. Moskovskiy gosudarstvennyy universitet imeni Lomonosova. (Sputtering (Physics)) (Copper crystals—Thermal properties)



#### 8/126/62/014/004/013/017 E193/E383

AUTHORS: Tyepunina, N.A., Predvoditelev, A.A., Yurasova, V.Ya.

Gusarova, S.M. and Zakharov, V.M.

TITLE: Distribution of impurities and dislocations in cadmium

crystals

PERIODICAL: Fizika metallov i metallovedeniye, v. 14, no. 4,

1962, 582 - 588

TEXT: It has been established by Borovskiy et al (Kristallografiya, 1962, 7, no. 4) that zinc tends to segregate at dislocations in cadmium crystals, the points of emergence of idslocations on the surface of a polished specimen being revealed by etching pits. It has also been found that in some specimens two systems of etch figures can be observed, their dimensions. being about  $1-2\,\mu$  and about  $0.1\,\mu$ , respectively. The object of the present investigation was to elucidate the causes of the appearance of these two systems of etch figures by studying the effect of the zinc concentration on the size and shape of the etching pits. The concentration of zinc in the experimental cadmium-zinc alloy specimens ranged from 0.01-10%. Electrolytic Card 1/4

S/126/62/014/004/015/017 E193/E383

Distribution of impurities '.

and ion-bombardment etching techniques were used to produce the etching pits. The etch figures were examined with the aid of an optical microscope in the case of alloys containing less than 4% Zn, an electron microscope being also used to examine the alloys with lower Zn contents. In some cases, cine-photography was employed to study the process of formation of etch figures. The angle between the surface of the polished specimen and the basal plane (0001) of cadmium ranged from 0 - 90°. Rows of small etching pits were observed in specimens with the zinc content lower than 1%. Both small and coarse etching pits were formed as the zinc concentration increased. In specimens with 4% Zn the formation of isolated hexagonal pits was observed. Starting from the zinc concentration of 6%, plate-like pits of regular hexagonal shape formed in the (0001) plane were observed only. of the small and coarse etch figures was practically independent of the zine concentration, which supported the view that the etch pits corresponded to the points of emergence of the dislocations on the surface of the specimens. The results of measurements of the etch pits formed on various alloys are reproduced in Fig.6, where the relative number  $(n_i/\sum n_i)$  of pits in a given specimen Card 2/4

## 8/126/62/014/004/015/017 E193/E383

Distribution of impurities .

is plotted against the etch-pits dimensions (d, u), the various graphs relating to alloys with the Zn content indicated. Comparison of these distribution curves with the constitution diagram of the cadmium/zinc system shows that alloys with a Zn content lower than the limit of its solid solubility in Cd at room temperature are characterized by one system of (small) etch figures. Two systems of etch figures are formed in two-phase alloys, each with a characteristic size of etching pit. It can be postulated that the system of the coarse etch figures cornesponds to dislocations decorated by the second-phase precipitates, whereas the fine etch figures correspond to dislocations with increased solute concentration, i.e. to Cottrell atmospheres. results of the present investigation were taken as a proof that the presence of dislocations considerably affected the distribution of Zn in the alloys studied. There are 6 figures and 1 table.

ASSOCIATION:

Moskovskiy gosudarstvennyy universitet im. M.V. Lomonosova (Moscow State University im.

M.V. Lomonosov) October 2, 1961

SUBMITTED:

APPROVED FOR RELEASE: 09/19/2001

CIA-RDP86-00513R001963210001-8"

## "APPROVED FOR RELEASE: 09/19/2001

1.21,29

s/048/62/026/011/021/021 B125/B102

AUTHORS:

Yurasova, V. Ye., and Murinson, E. A.

TITLE:

Peculiarities of anisotropy in the cathode sputtering of single crystals

PERIODICAL:

Akademiya neuk SSSR. Izvestiya. Seriya fizicheskaya v. 26, no. 11, 1962, 1445-1448

TEXT: The anisotropy of hexagonal crystals is studied on cylindrical zinc single crystals with the bacal plane (0001). The most densely packed directions (1120) were perpendicular to the cylinder axis. The specimen (of about the same height and diameter) was attached to a glass tube and surrounded by a glass or mica collector. The glass tube contained a low pressure plasma (10-3 mm Hg) of high density (1013 cm-3). The test sputtering 1 hr. The substance of hexagonal crystals, like that of cubic crystals, is mainly atomized in the direction of the densest packing.

Peculiarities of anisotropy ...

\$/048/62/026/011/021/021 B125/B102

Cathode sputtering of zinc single crystals onto a cylindrical glass collector supplied sufficiently distinct spot patterns. The intensity of these spots decreases from the center toward the spot margin according to  $I/I_{\alpha}(\alpha)$  = e •cos $\alpha$ , where  $p_{\alpha} = 9.5$  for  $Zn_{\alpha}$  and  $p_{\alpha} = 3.3$  for Cuin Kr. In the evaporation of a monocrystalline copper sphere (d = 4 am) and at ratios  $\mu$  = d/1 between 0.1 and 0.33, the photometric curves remain nearly constant, and resemble the curves for the plane specimen. d is the diameter of the sphere, and 1 is the distance between collector and specimen. The angular size of the spot is  $\tan(\delta/2) = \tan(\delta_0/2) + \mu/2$ for a plane specimen, where  $\delta_{o}$  is the angular size of the atomized spot when the collector is infinitely distant. The linear size  $D_0 \approx 2e \tan(\delta_0/2) + d_0$  of the spot decreases with decreasing distance to the collector, but always remains greater than the diameter of the plane specimen. The linear size of the sputtered spot remains smaller than the specimen diameter in the case of spherical specimens and spherical collectors when the screen is sufficiently near ( $\mu = 0.5$ ). This is due to

APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

## 8/181/65/005/002/024/051 B104/B102

AUTHORS:

Predvoditelev, A. A., Spivak, G. V., Kotova, A. K.,

jurasova, V. Ye., and Kushnir, F. F.,

TITLE:

litudy of nen-decored dislocations in sinc single crystals

by ion bombardment

PERIODICAL: Fisika tverdogo tola, v. 5, no. 2, 1963, 542-545

TEXT: This paper is simed to prove the possibility of detecting "virgin" dislocations by ion bombardment of single-crystal faces. Cylindrical sinc single crystals (2.5 mm in diameter, 50 mm high) were split along the (0001) plane at hitrogen temperature and the faces were hombarded with ions in flowing mean gas. Thin pieces of specimens that had been bombarded with ions on both (0001) planes showed the same etch patterns on both sides. Repeated etching of any one surface section produces no new etch patterns but intensifies those existing. The results from chemical etching and from ion bombardment are consistent. The most favorable experimental conditions are: neon pressure between 6.10 and

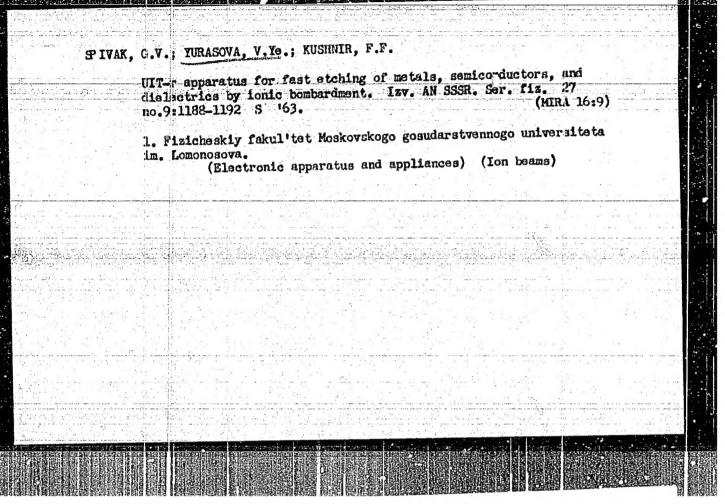
Card 1/2

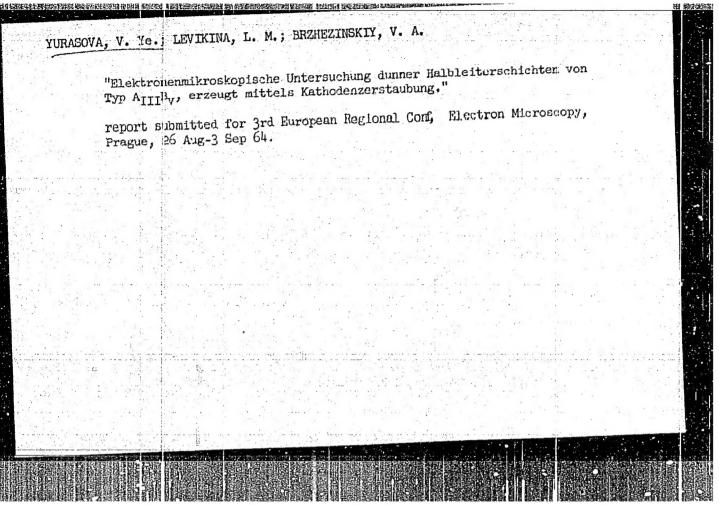
Study of non-decored dislocations ... B104/E102

3'10<sup>-2</sup> mm Eg, voltage between anode and gpecimen between 1.5 and 1.75 kv, ourrent density at the specimen 1.2 a/on<sup>2</sup>, bonbardment period, approximately one hour. There are 5 figures.

ASSOCIATION: Moskovskiy gosudarstvennyy universitet im. M. V. Lomonosova (Moscow State University imeni M. V. Lomonosova (Moscow State University imeni M. V. Lomonosov)

SUBMITTED: June 25, 1962 (initially)
August 29, 1962 (after revision)





APPROVED FOR RELEASE: 09/19/2001 CIA-RDP86-00513R001963210001-8"

